



IPW

PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Deming Shu et al.

Application: **ROBOT-BASED AUTOMATION SYSTEM FOR CRYOGENIC CRYSTAL SAMPLE MOUNTING**

Serial No.: 10/807,599

Filing Date: March 24, 2004

Art Unit: 3744

Examiner: William C. Doerrler

Case: ANL-IN-02-072

CERTIFICATE OF MAILING: I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner of Patents, P.O. Box 1450, Alexandria, VA, 22313-1450, on

August 21, 2006

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Chicago, Illinois 60611

Mail Stop Amendment  
Commissioner Of Patents  
P.O Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action mailed August 7, 2006, please amend  
the above-identified application as follows: